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Application Number	10/734,699
Filing Date	Dec. 12, 2003
First Named Inventor	Robert Todd Belt
Group Art Unit	
Examiner Name	
Attorney Docket Number	RTB001US

(use as many sheets as necessary)

Sheet	1	of	3
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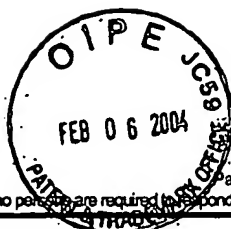
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PTO/SB/08A (10-96)

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet **2** of **3**

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OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials ²	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
<i>[Signature]</i>	8	Bifano, Thomas G. et al., "Continuous-membrane Surface-micromachined Silicon Deformable Mirror" <i>Optical Engineering</i> 36:5 (May 1997) p. 1354-1360.	
	9	Ealey, Mark A. et al., "Continuous Facsheet Low Voltage Deformable Mirrors" <i>Optical Engineering</i> 29:10 (October 1990) p. 1191-1198.	
	10	Hulburd, Bill et al., "Segmented Mirrors for Atmospheric Compensation" <i>Optical Engineering</i> 29:10 (October 1990) p. 1186-1190.	
	11	Lim, C.W. et al., "Three-dimensional Electromechanical Responses of a Parallel Piezoelectric Bimorph" <i>International Journal of Solids and Structures</i> , Vol. 38 (2001) p. 2833-2849.	
	12	Mali, Raji Krishnamoorthy et al., "Development of Microelectromechanical Deformable Mirrors For Phase Modulation of Light" <i>Optical Engineering</i> 36:2 (February 1997) p. 542-548.	
	13	Morris, Christopher J. et al., "Optimization of a Circular Piezoelectric Bimorph for a Micropump Driver" <i>Journal of Micromechanical Microengineering</i> , Vol. 10, (2000) p. 459-465.	
	14	Hoffmann et al., "Fabrication and Characterization of a PZT Thin Film Actuator for a Micro Electromechanical Switch Application" <i>Materials Research Society Symposium Proceedings</i> Vol. 688, C5.9 (2002) p. 145-152.	
	15	Roggemann, Michael C. et al., "Use of Micro-electro-mechanical Deformable Mirrors to Control Aberrations in Optical Systems: Theoretical and Experimental Results" <i>Optical Engineering</i> 36:5 (May 1997) p. 1326-1338.	
	16	Shwartz, Josef et al., "Tactical High Energy Laser" SPIE Proceedings on Laser and Beam Control Technologies" Vol. 4632 (January 21, 2002).	
	17	Vdovin, Gleb et al., "Technology and Applications of Micromachined Silicon Adaptive Mirrors" <i>Optical Engineering</i> 36:5 (May 1997) p. 1382-1390.	
<i>[Signature]</i>	18	Winsor, R. et al., "Finite Element Analysis of Low Cost Membrane Deformable Mirrors for High Order Adaptive Optics" Proceedings of SPIE - High Resolution Wavefront Control: Methods, Devices and Applications, Denver, Colorado (July 19-20, 1999) p. 2-11.	

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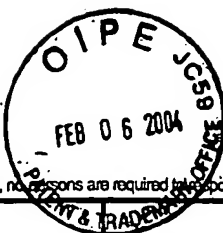
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	19	Winsor, R. et al., "Low Cost Membrane Type Deformable Mirror With High Density Actuator Spacing" Proceedings of SPIE - Adaptive Optical Systems and Technology, Munich, Germany (March 29-31, 2000) p. 563-572.	
	20	Yang, Eui-Hyeok (EH) et al., "Design and Fabrication of Electrostatic Actuators With Corrugated Membranes for MEMS Deformable Mirror in Space" Proceedings of SPIE - Imaging Technology and Telescopes, San Diego, California, Vol. 4091 (July 30-31, 2000) p. 83-89.	

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